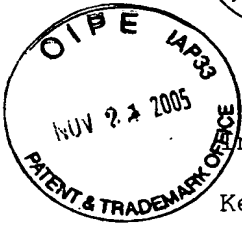
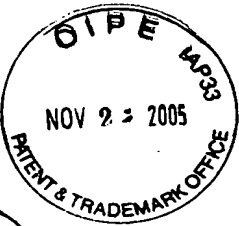


IFW

PATENT
8032-1029



IN THE U.S. PATENT AND TRADEMARK OFFICE

Re application of

Kenichi ISHII

Conf. 4870

Application No. 10/623,545

Group 2687

Filed July 22, 2003

Examiner Dung Le Lam

LOCATION SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed Form PTO-1449.

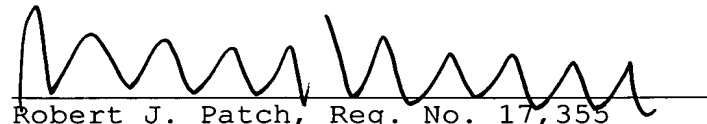
A concise explanation of the relevance of these items is that these references were cited by the Korean Patent Office in the corresponding Korean patent application. A copy of the Korean Official Action in which they were cited is attached hereto. A Japanese translation of the Korean Official Action is also enclosed with what is believed to be the pertinent portion enclosed in a wavy line. **An English translation of the enclosed portion is also attached hereto.**

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a

counterpart foreign application not more than three months
prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON

A handwritten signature in black ink, appearing to read "Robert J. Patch", is written over a horizontal line.

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RJP/lrs

November 21, 2005

* Abstract provided for the Examiner's convenience